

U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/2981/ECORE/ CORE/MBE	Serial No. 09/220,153
MAR 14 2002			

**LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT**

(Use several sheets if necessary)

Examiner R. Bueker

Applicant  
Reimer, et al.Confirmation No.  
3858

Filing Date

December 23, 1998

Group

1763

**U.S. Patent Documents**

Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
	A1						
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						

**Foreign Patent Documents**

Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
RRB	B1	JP 2-184333 w/ English Abstract	07-18-1990	Japan	B01J	3/02		X
RRB	B2	JP 4-358531 w/ English Abstract	12-11-1992	Japan	B01J	3/02		X
RRB	B3	JP 6-29367	02-04-1994	Japan	H01L	21/58		X
RRB	B4	JP 7-167053 w/ English Abstract	07-04-1995	Japan	F04B	37/16		X
RRB	B5	JP 8-74041	03-19-1996	Japan	C23C	14/24		X
RRB	B6	JP 9-168732 w/ English Abstract	06-30-1997	Japan	B01J	3/02		X
RRB	B7	JP 9-251981 w/ English Abstract	09-22-1997	Japan	H01L	21/2065		X

**OTHER ART**

Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	

Examiner R. Bueker Date Considered 10 - 2003

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

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TC 1700

U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/2981/IBSS/CP S/BG	Serial No. 09/220,153
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICATION</b>		Applicant Applied Materials, Inc.	Confirmation No.: 3858
(Use several sheets if necessary)		Filing Date	Group
	Examiner R. Beuker	December 23, 1998	1763

**U.S. Patent Documents**

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
RRB	A1	5,944,049	08-31-1999	Beyer et al.	137	487.5	07-15-1997
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						
	A12						
	A13						

**Foreign Patent Documents**

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
	B1						<input type="checkbox"/>	<input type="checkbox"/>
	B2						<input type="checkbox"/>	<input type="checkbox"/>
	B3						<input type="checkbox"/>	<input type="checkbox"/>

**OTHER ART**

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	
	C3	

Examiner R. Beuker Date Considered 10 - 2003

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<b>LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT</b>		Applicant Applied Materials, Inc.	Confirmation No.: 3858
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	A1						
	A2						
	A3						
	A4						
	A5						
	A6						
	A7						
	A8						
	A9						
	A10						
	A11						
	A12						

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							YES	NO
	B1						<input type="checkbox"/>	<input type="checkbox"/>
	B2						<input type="checkbox"/>	<input type="checkbox"/>
	B3						<input type="checkbox"/>	<input type="checkbox"/>
	B4						<input type="checkbox"/>	<input type="checkbox"/>
	B5						<input type="checkbox"/>	<input type="checkbox"/>

**OTHER ART**

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
R R B	C1	Various pages describing a Model IPX100 Dry Vacuum Pump and illustration showing the position of the pump relative to a semiconductor processing apparatus, 4 pps.
	C2	
	C3	

Examiner R. Buehr Date Considered 7 - 2002

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.

U.S. PENDING PATENT APPLICATION

ATTORNEY DOCKET NO.: 2981/USA/SMO/PJS  
SERIAL NO.: N/A - FILED: HEREWITH  
INVENTORS: REIMER, ET AL.

EXAMINER'S INITIALS	PENDING U.S. PATENT APPLICATION(S)
AA	U.S. Patent Application entitled, "An Apparatus and Method for Regulating a pressure in a Chamber," filed _____; Serial No. _____; Inventors: Beyers, et al.
AB	
AC	
AD	
AE	
AF	
AG	
AH	
AI	
AJ	

*Richard Bush* 10-2003